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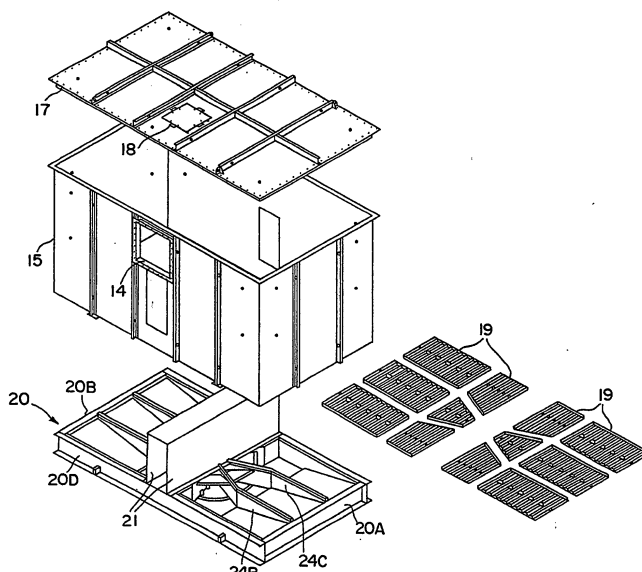
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(54) **Switching valve seal**

(57) Switching valve utilizing a rotatable seal suitable for use in a regenerative thermal oxidizer (10), and oxidizer (10) including the switching valve (20). The valve (20) of the present invention exhibits excellent sealing characteristics and minimizes wear. The valve (20) has a seal plate (100) that defines two chambers, each chamber being a flow port (25) that leads to one of two regenerative beds of the oxidizer (10). The valve (20) also includes a switching flow distributor (50) that provides alternate channelling of the inlet or outlet process gas to each half of the seal plate. The valve operates between two modes: a stationary mode and a valve movement mode. In the stationary mode, a tight gas seal is used to minimize or prevent process gas leakage. The gas seal also seals during valve movement.

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**FIG. 2**



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# EUROPEAN SEARCH REPORT

Application Number  
EP 06 07 7006

DOCUMENTS CONSIDERED TO BE RELEVANT			
Category	Citation of document with indication, where appropriate, of relevant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (IPC)
A	US 5 692 892 A (HOUSTON REAGAN [US]) 2 December 1997 (1997-12-02) * column 1, line 6 - line 9 * * figures 9,10 * -----	1-14	INV. F23L15/02 F27D17/00 F23G7/06
			TECHNICAL FIELDS SEARCHED (IPC)
			F23G F27D F23L
The present search report has been drawn up for all claims			
Place of search		Date of completion of the search	Examiner
The Hague		9 June 2008	Peis, Stefano
<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons ..... &amp; : member of the same patent family, corresponding document</p>			

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EPO FORM 1503 03.82 (P04C01)

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US 5692892	A	02-12-1997	NONE
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For more details about this annex : see Official Journal of the European Patent Office, No. 12/82